



**DEVELOPMENT AND INTEGRATION
OF A LOW COST, HIGH VOLTAGE
POWER SUPPLY INTO A THIN FILM
DEPOSITION SYSTEM**

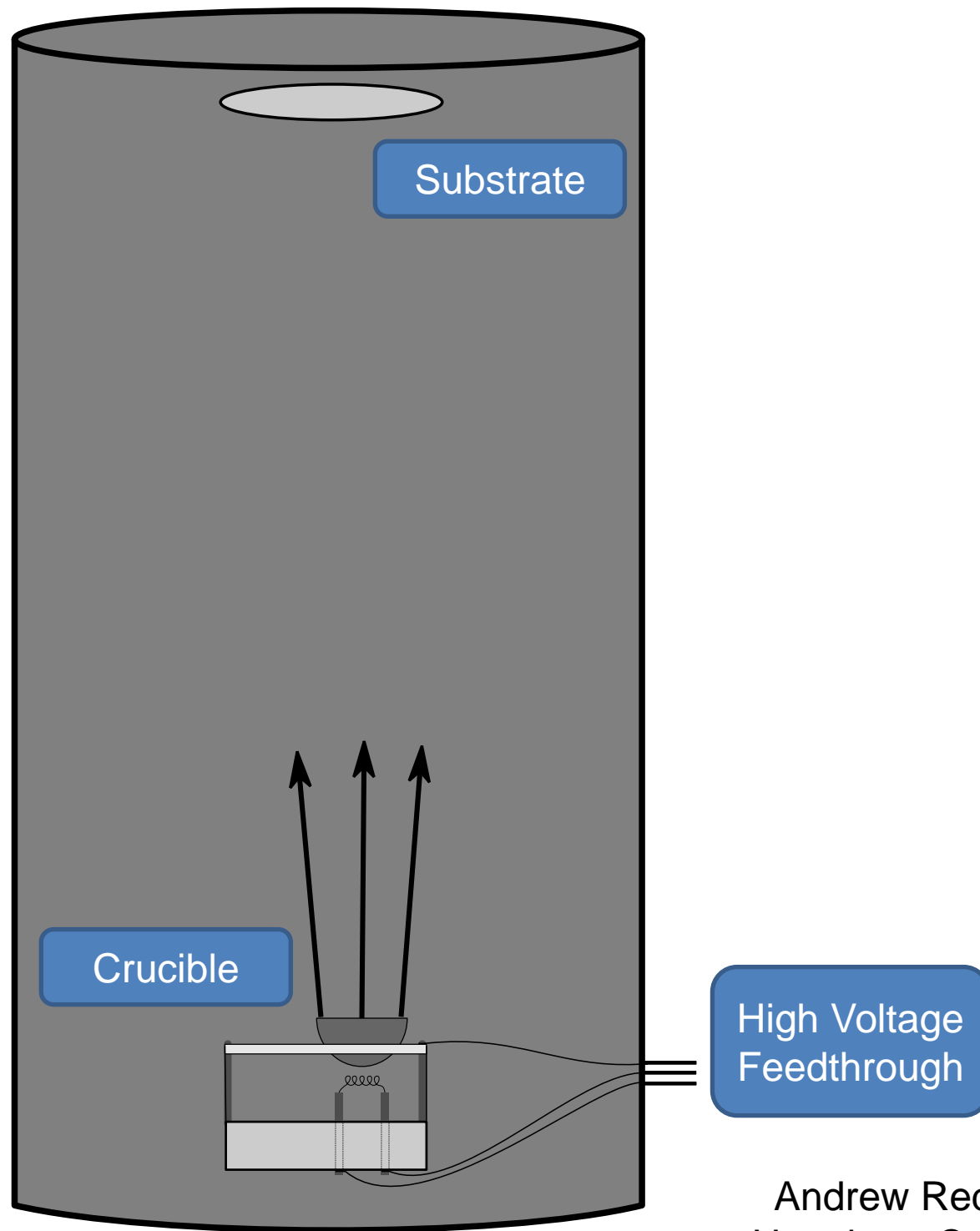
Andrew Redman
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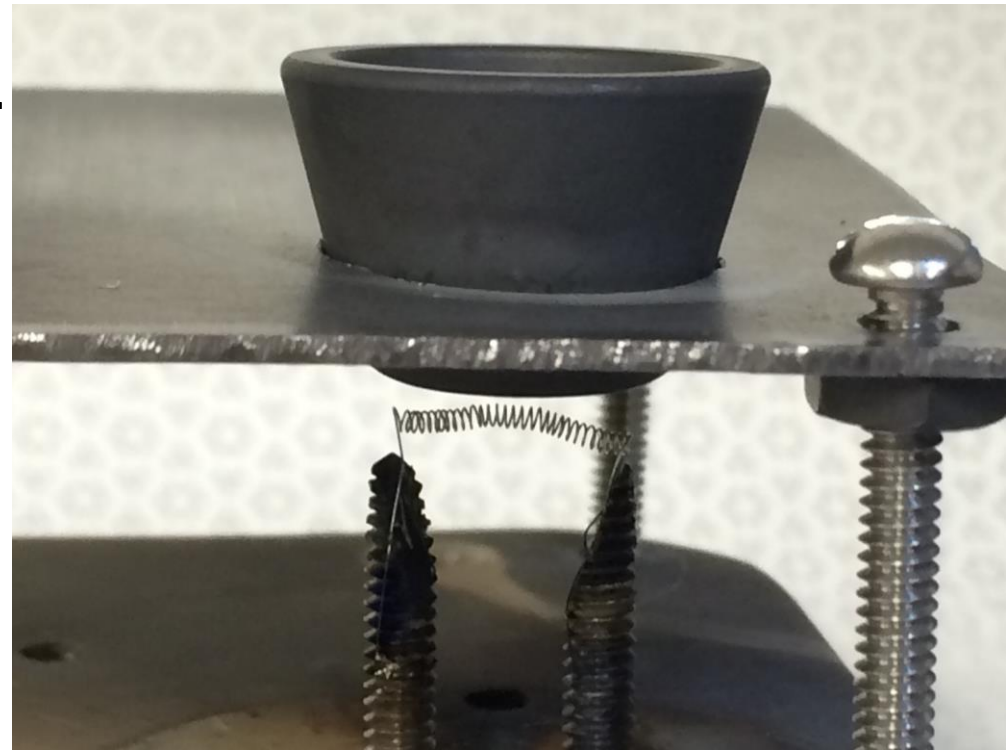
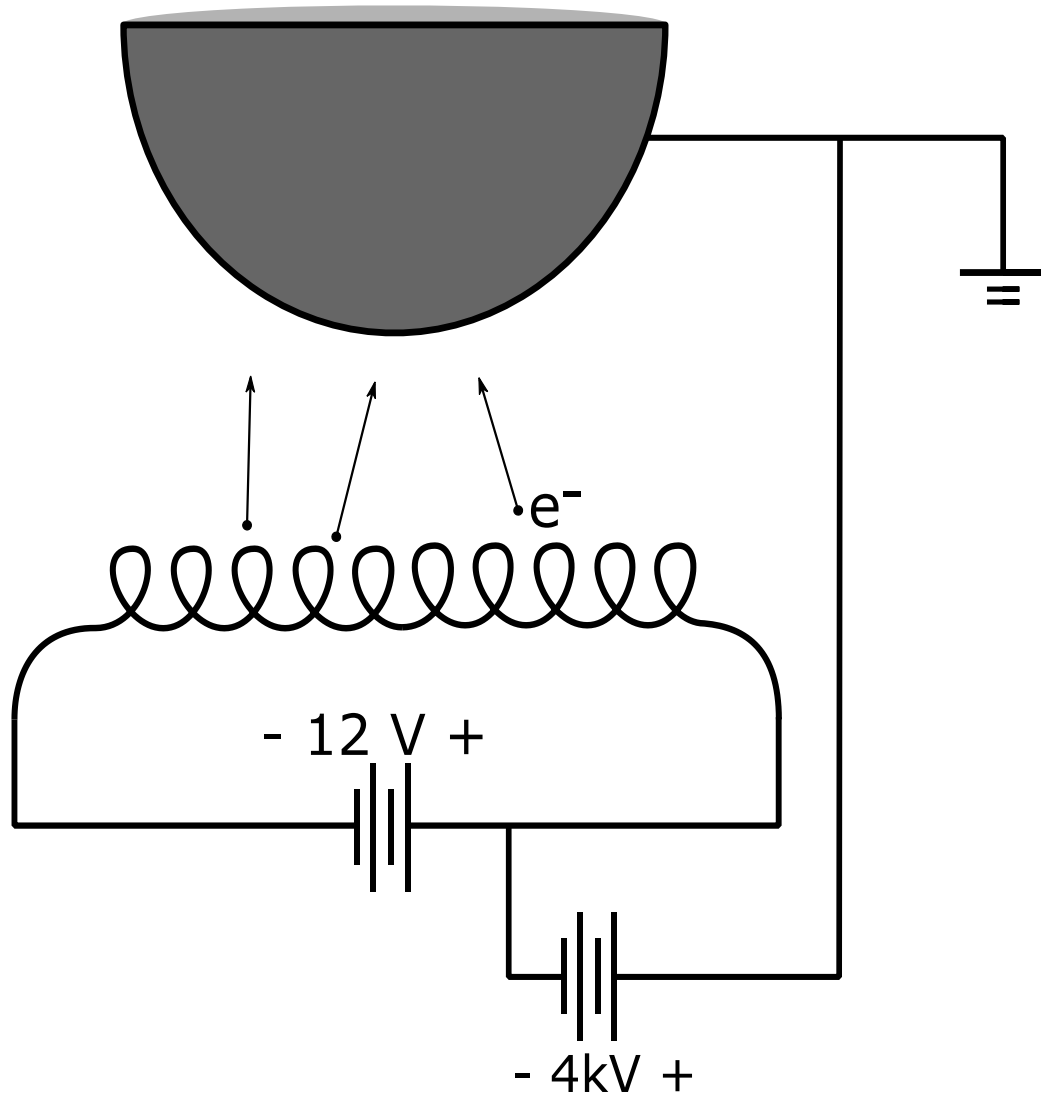
Thin Film Applications

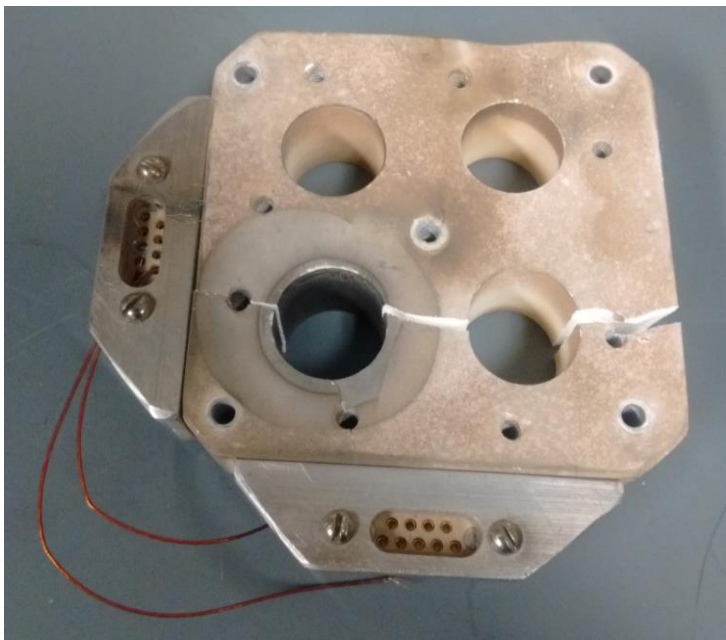
- Transistors
- Semiconductors
- Microcontrollers
- Computer Chips



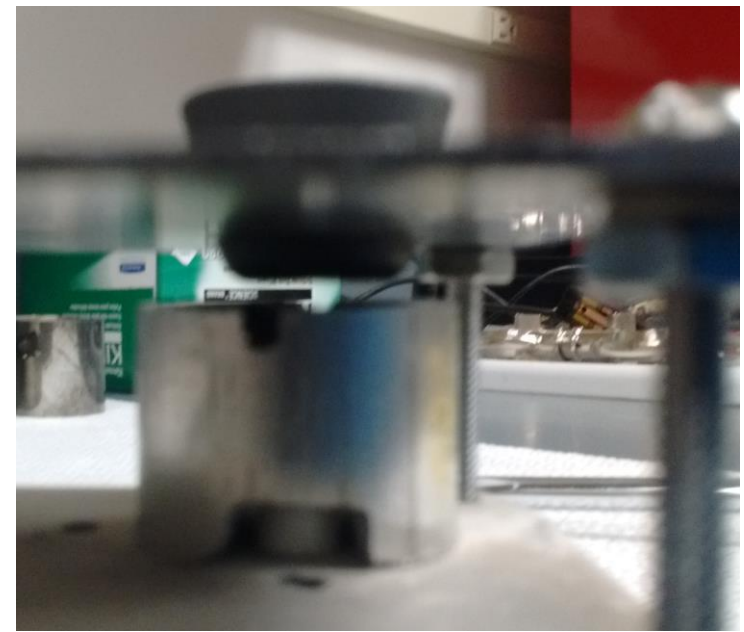


The Crucible





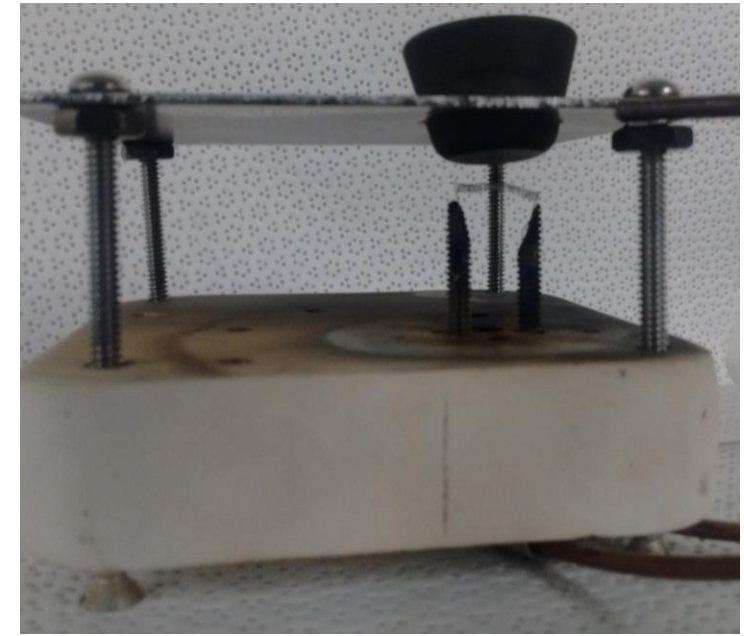
1



2

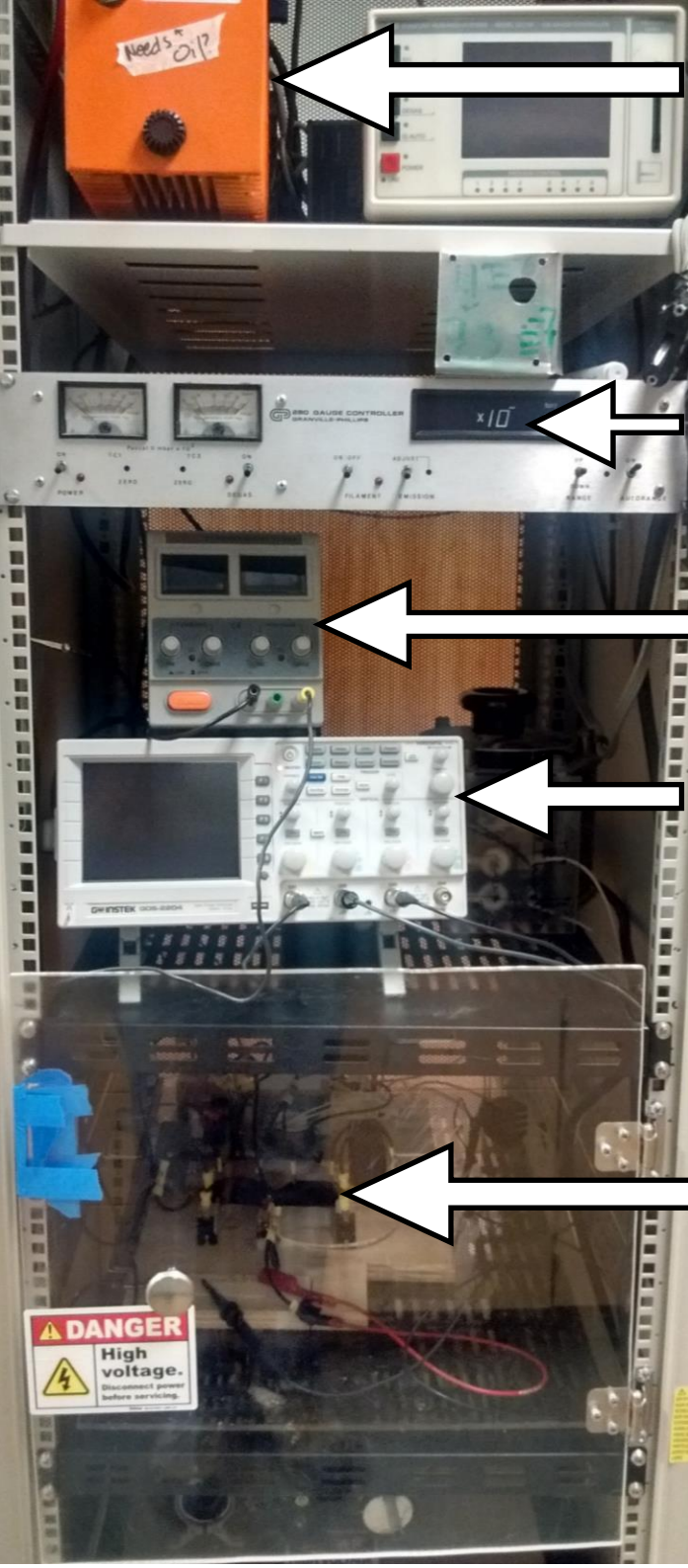


3



4

5



Rough Pump

Turbo Pump

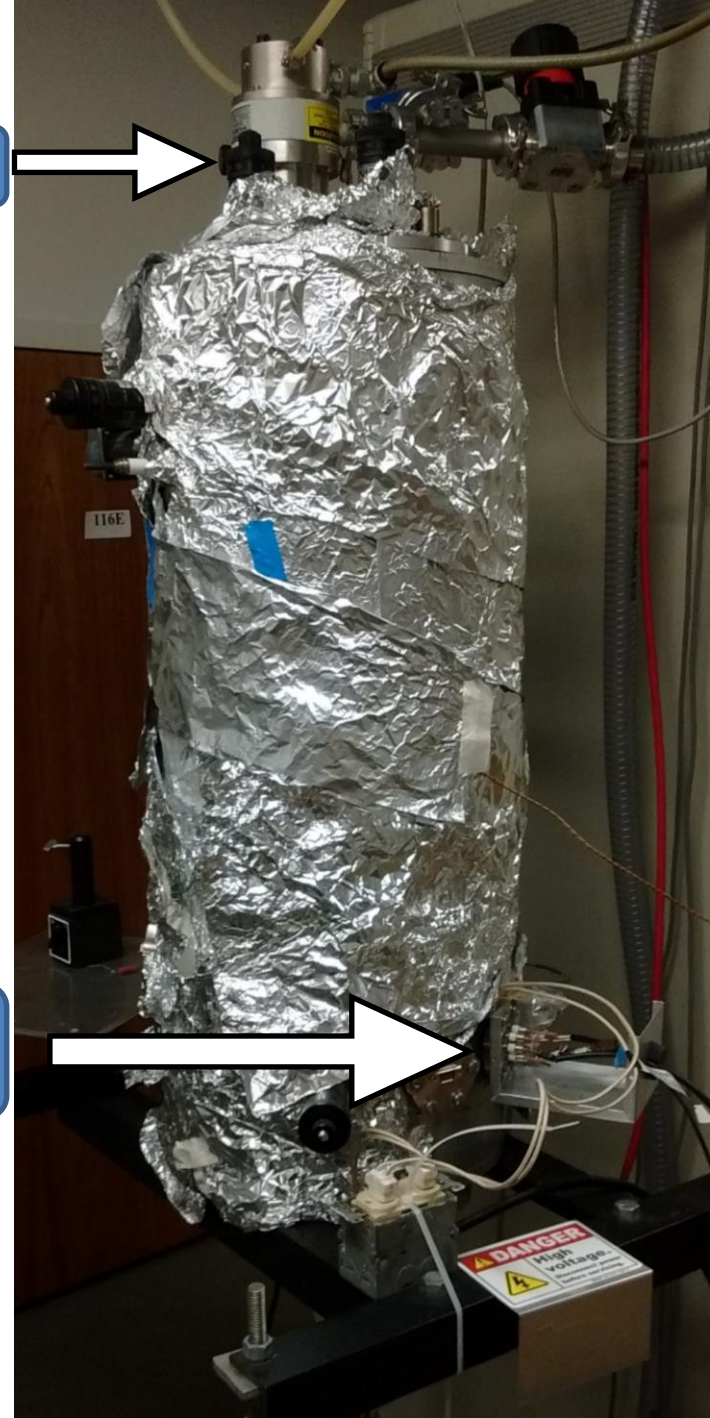
Pressure Gauge

Safety Power Supply

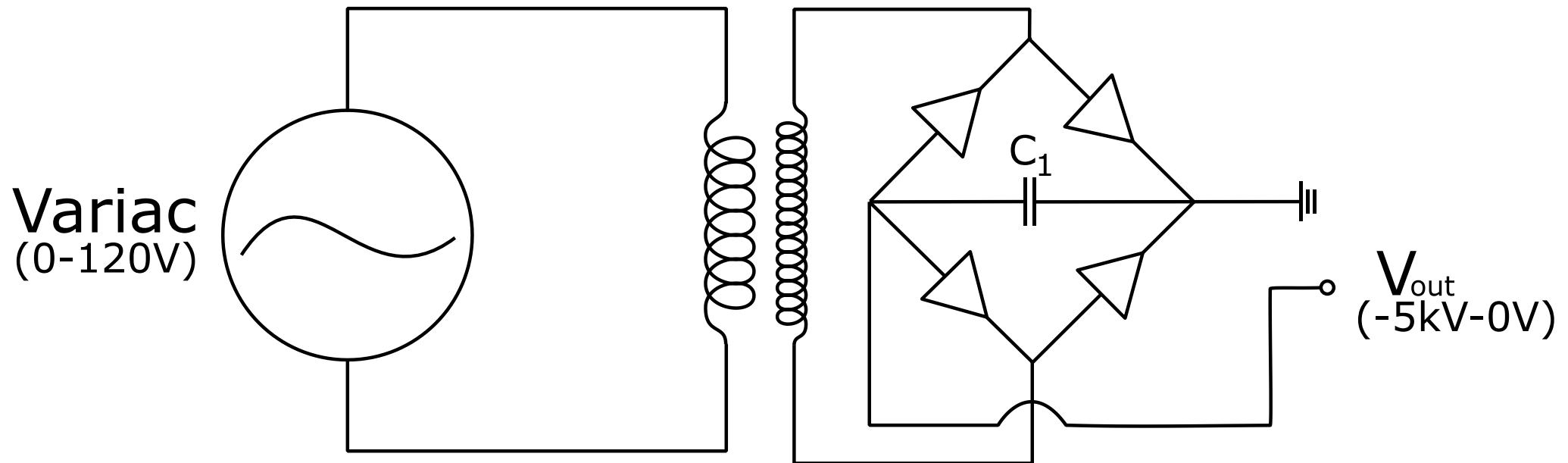
Oscilloscope

High Voltage Feedthrough

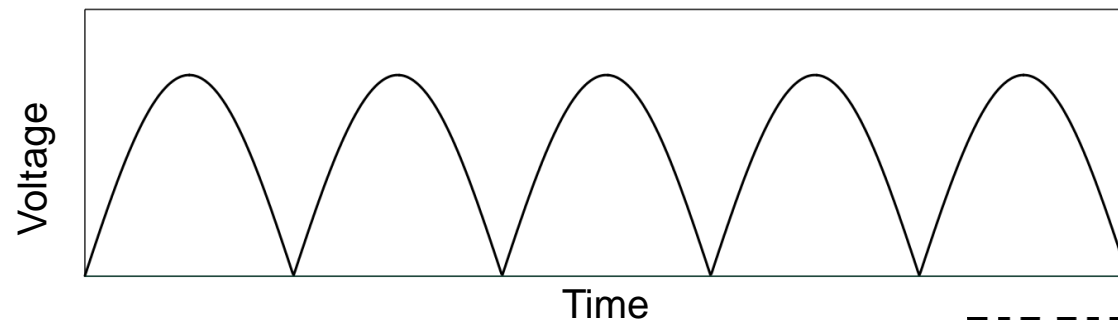
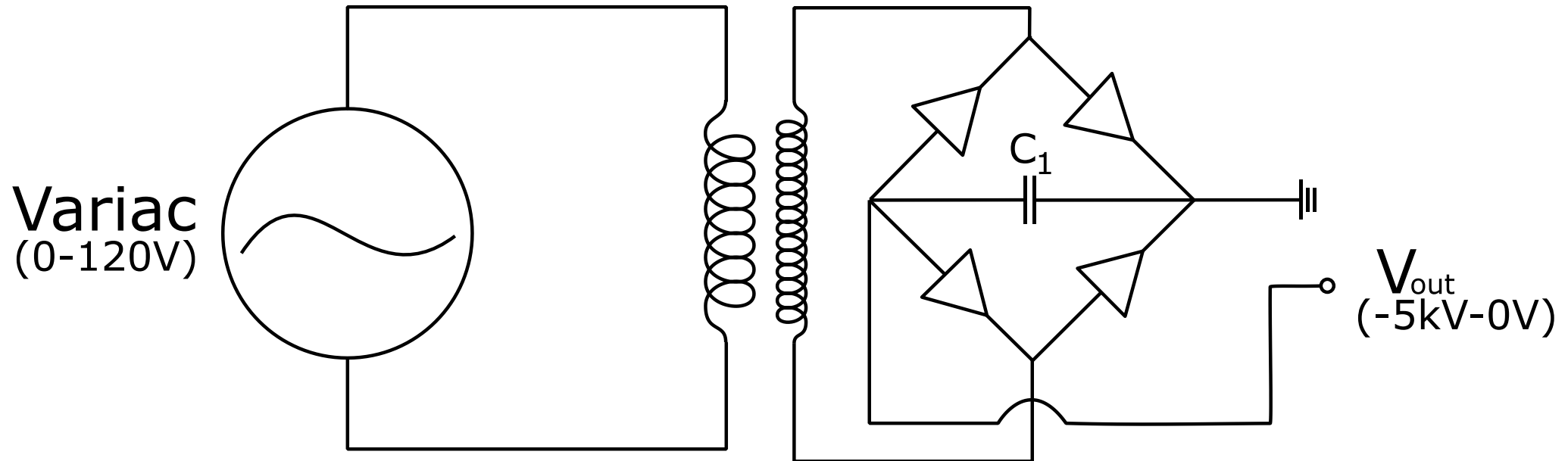
High Voltage Electronics



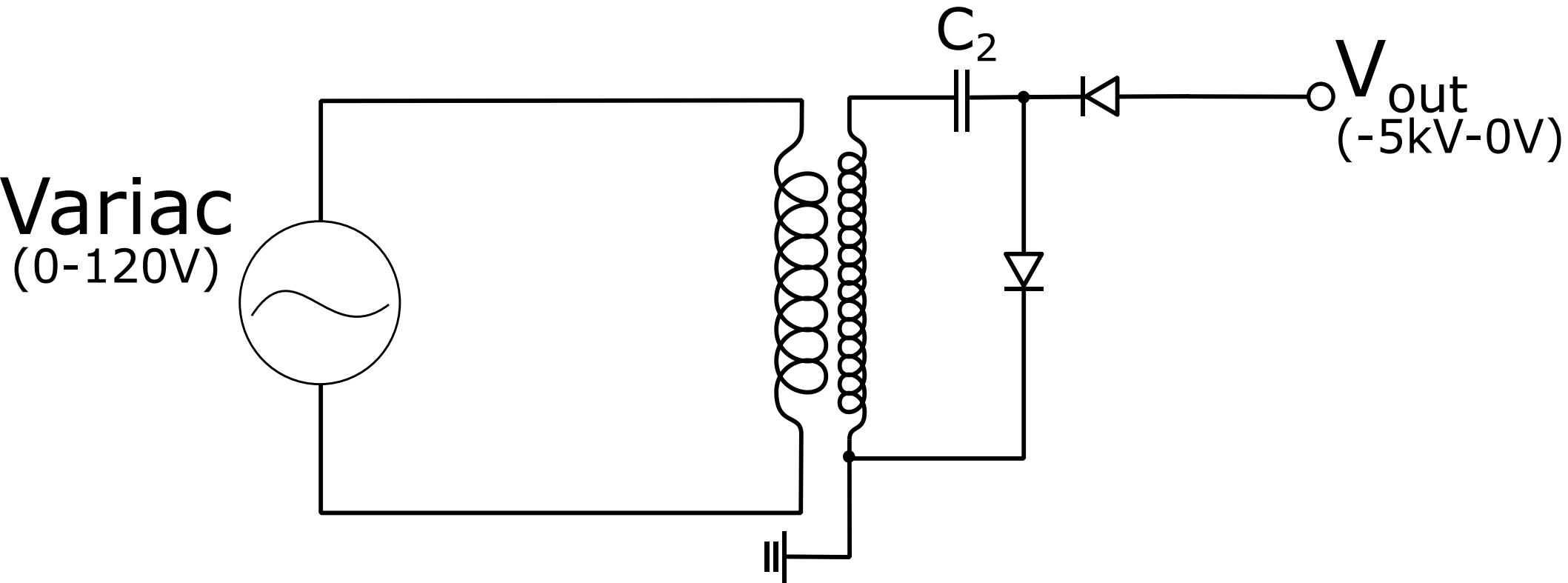
Original Circuit Design



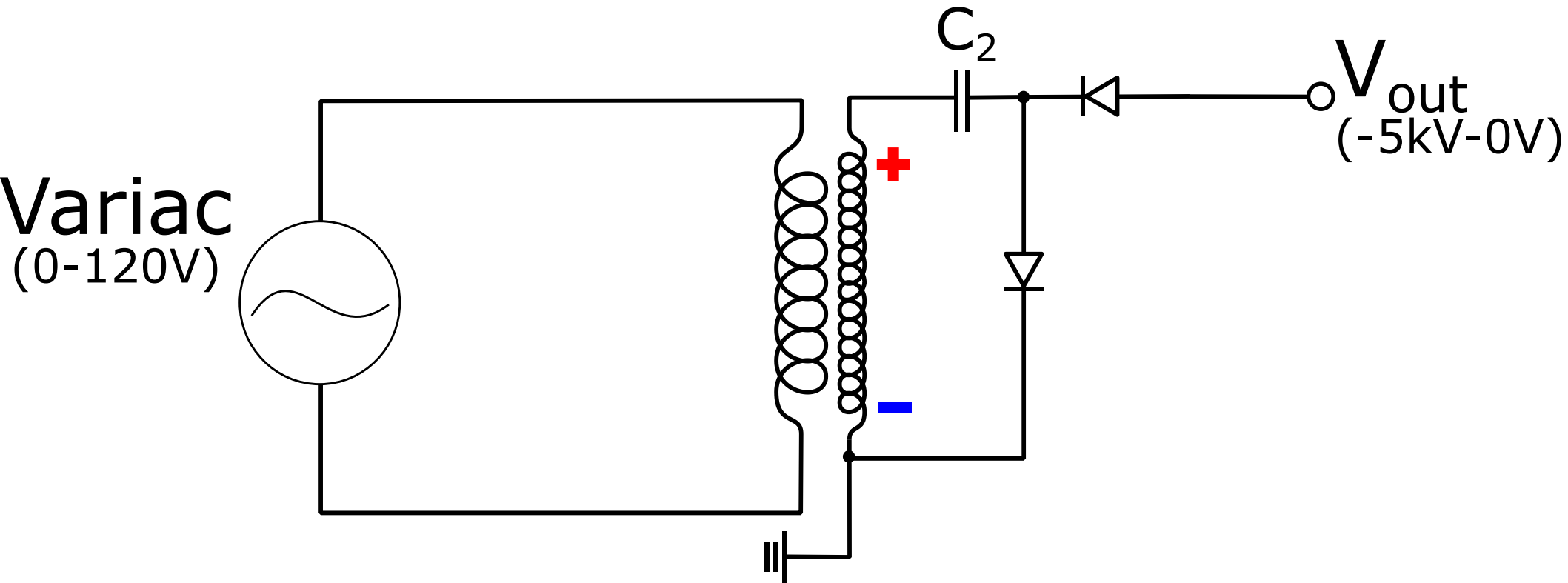
Original Circuit Design



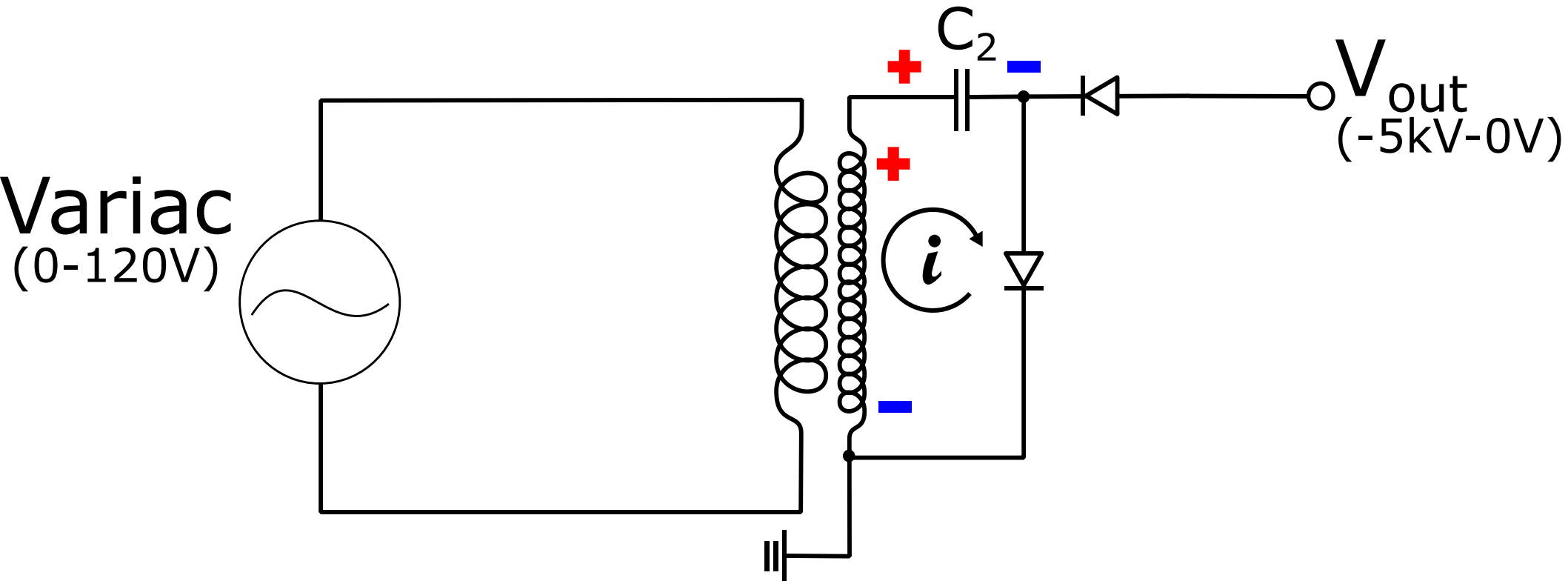
New Circuit Design



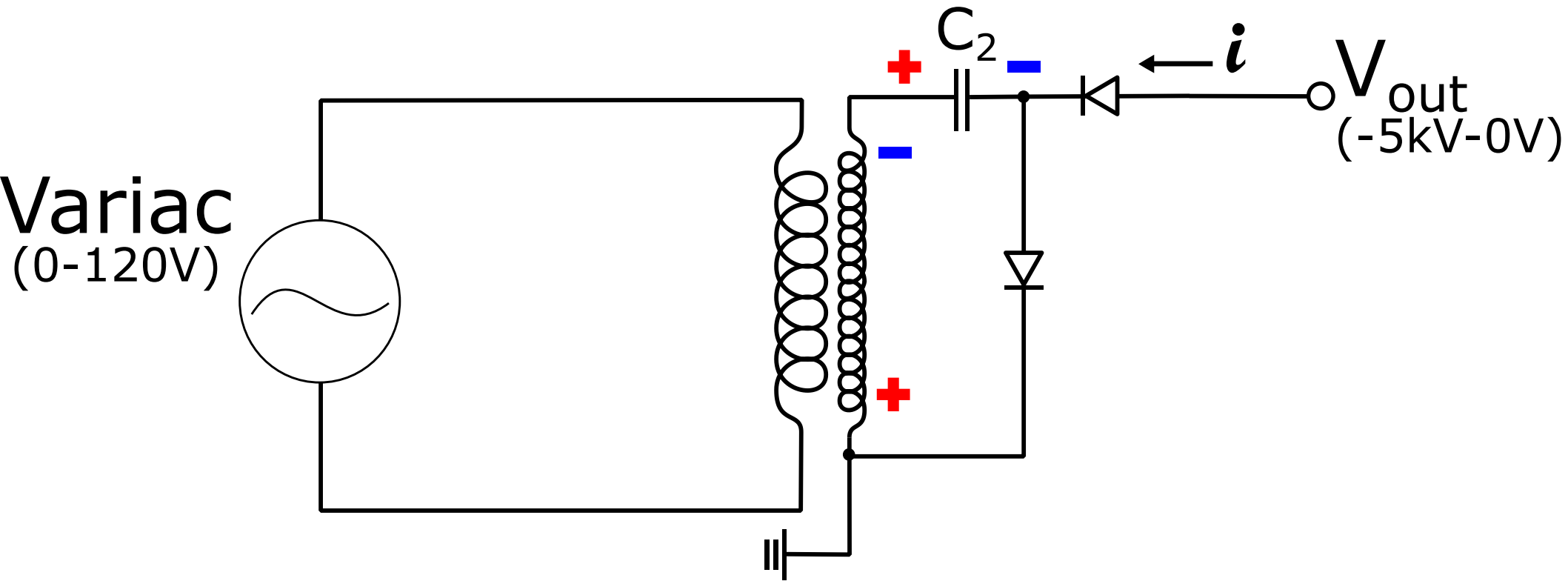
New Circuit Design



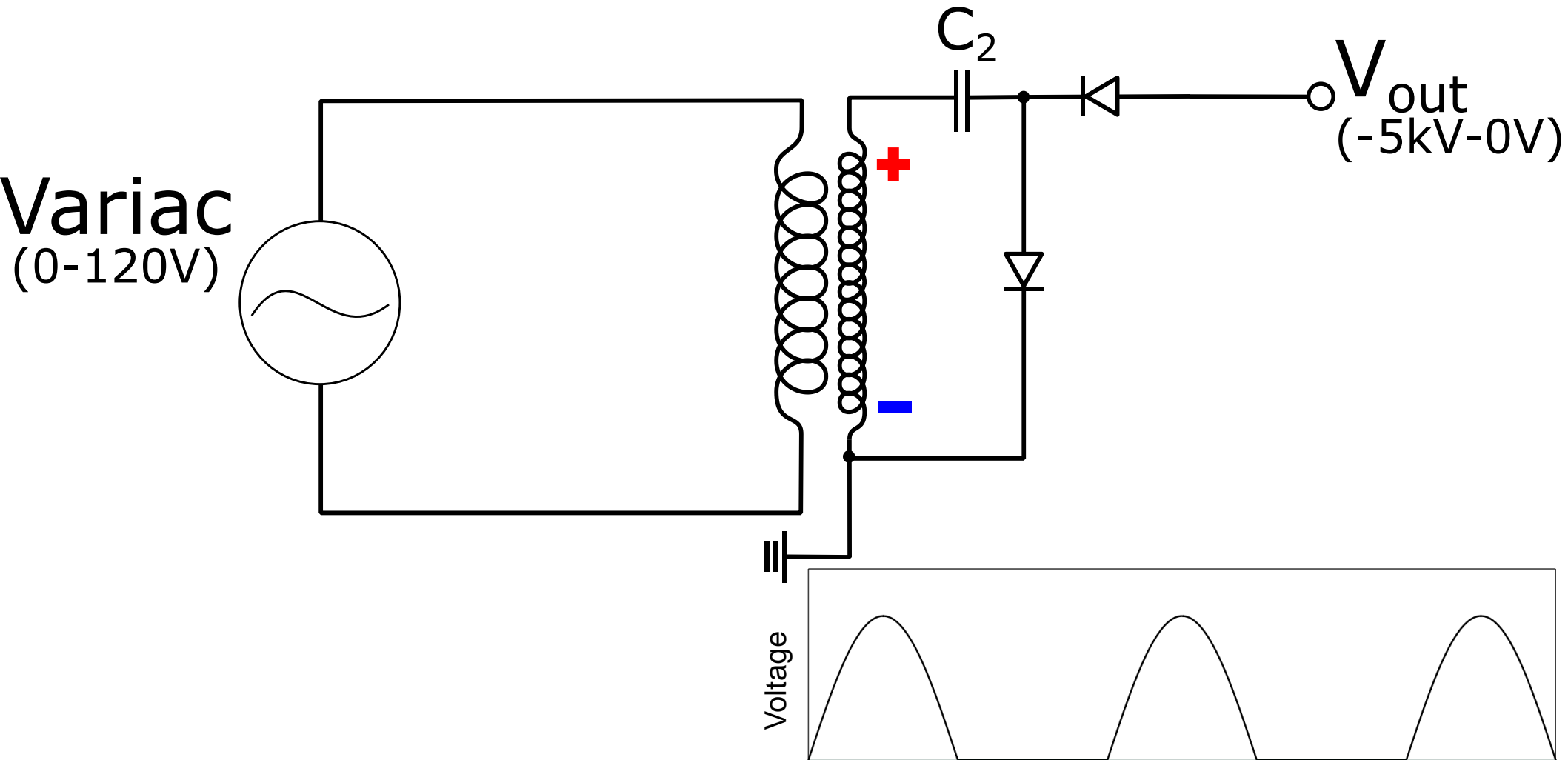
New Circuit Design



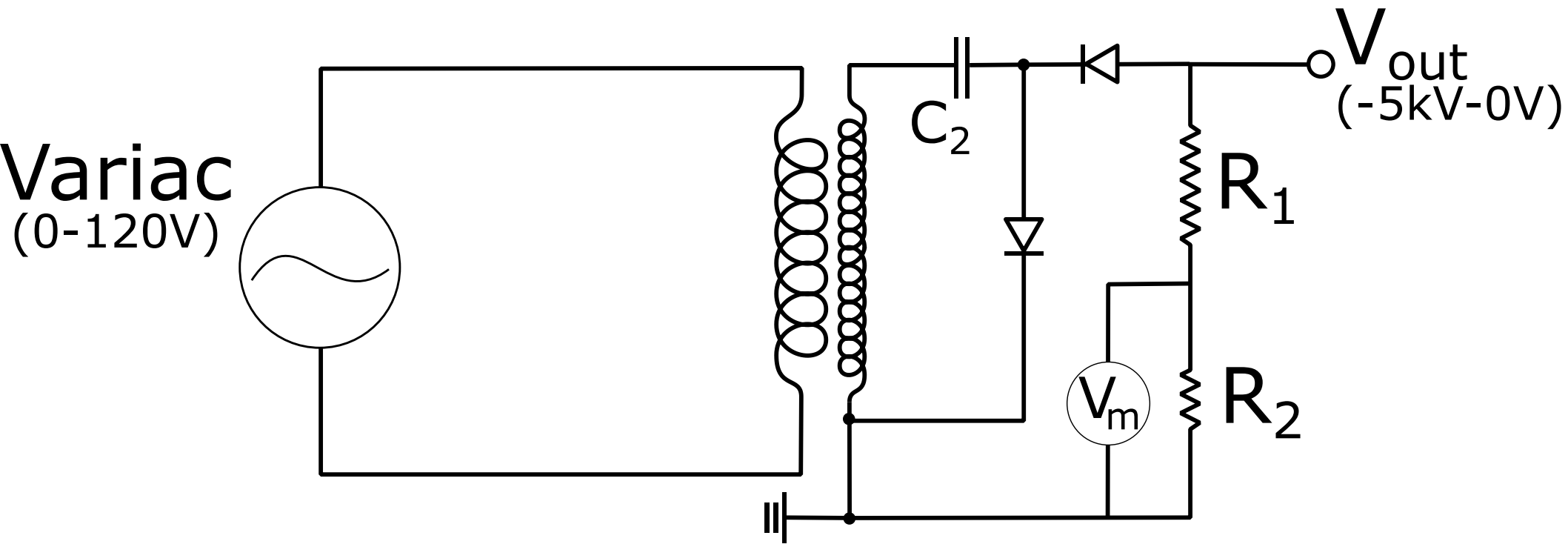
New Circuit Design



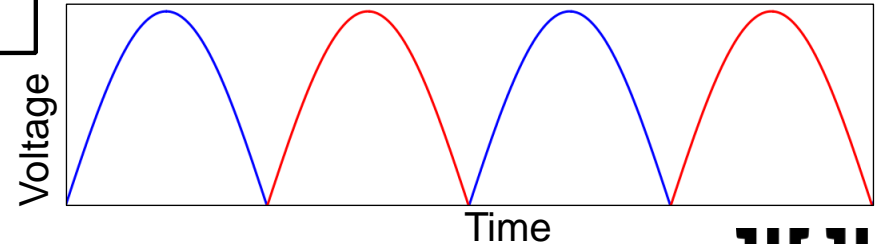
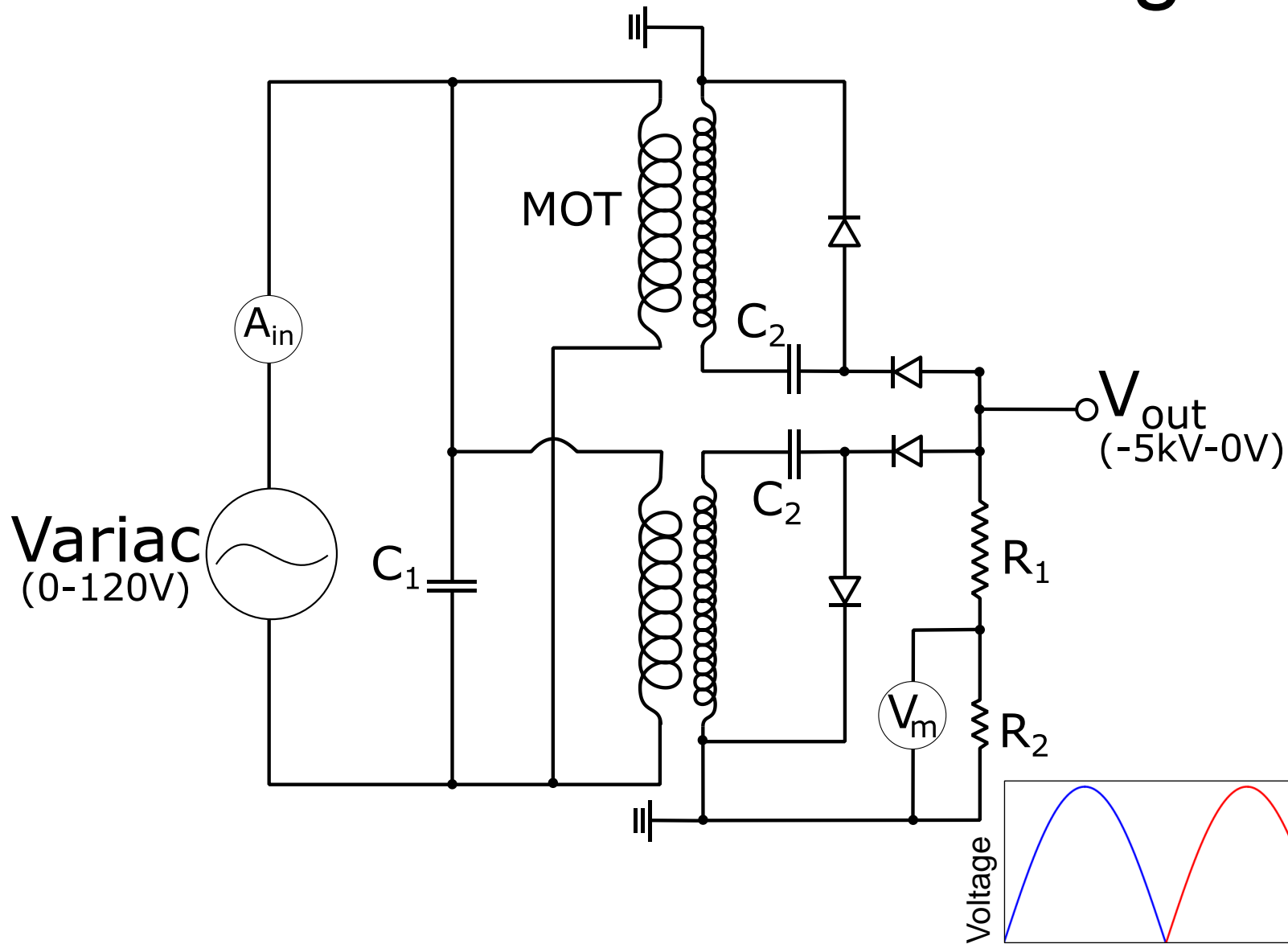
New Circuit Design



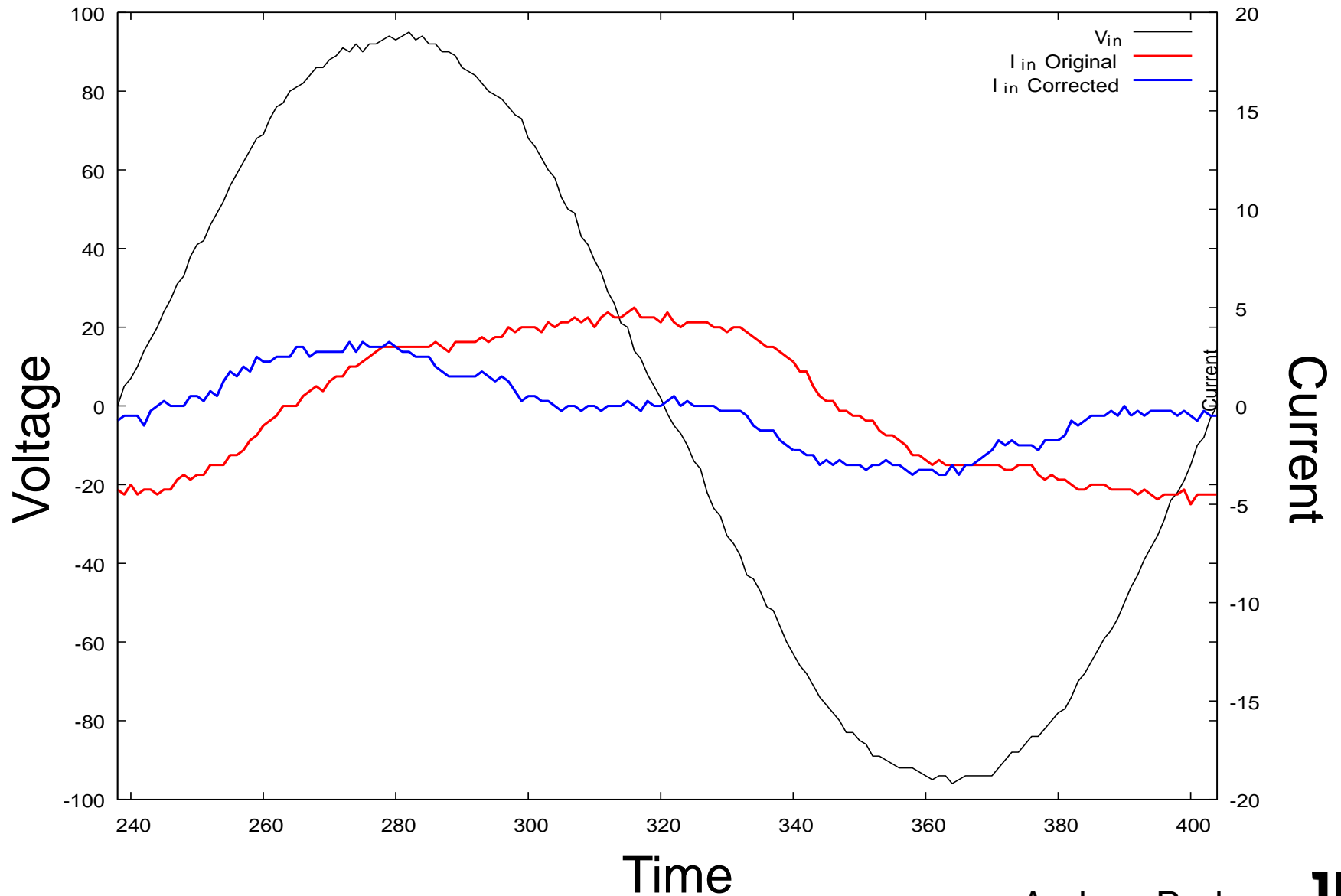
New Circuit Design



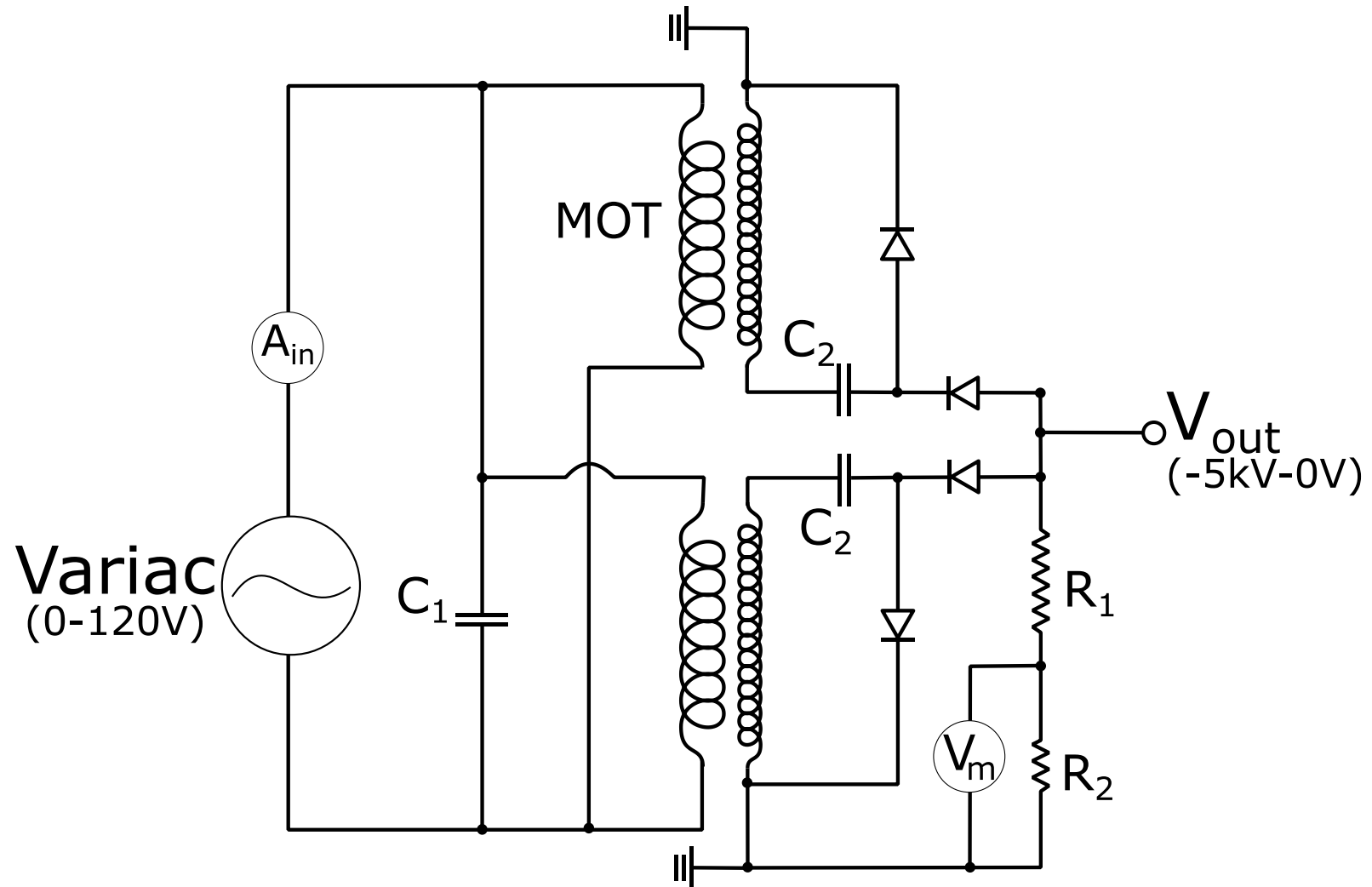
New Circuit Design



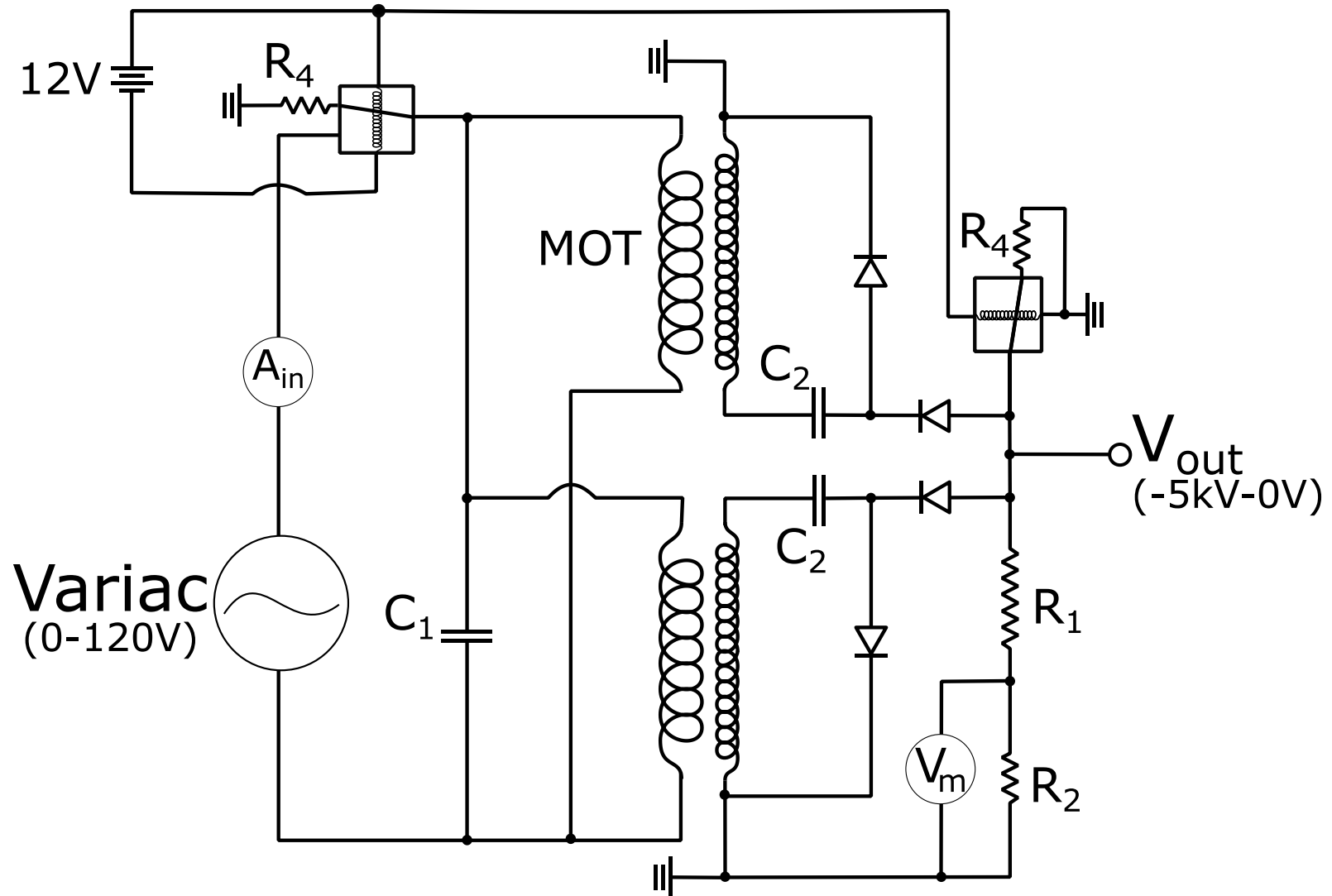
Phase Difference



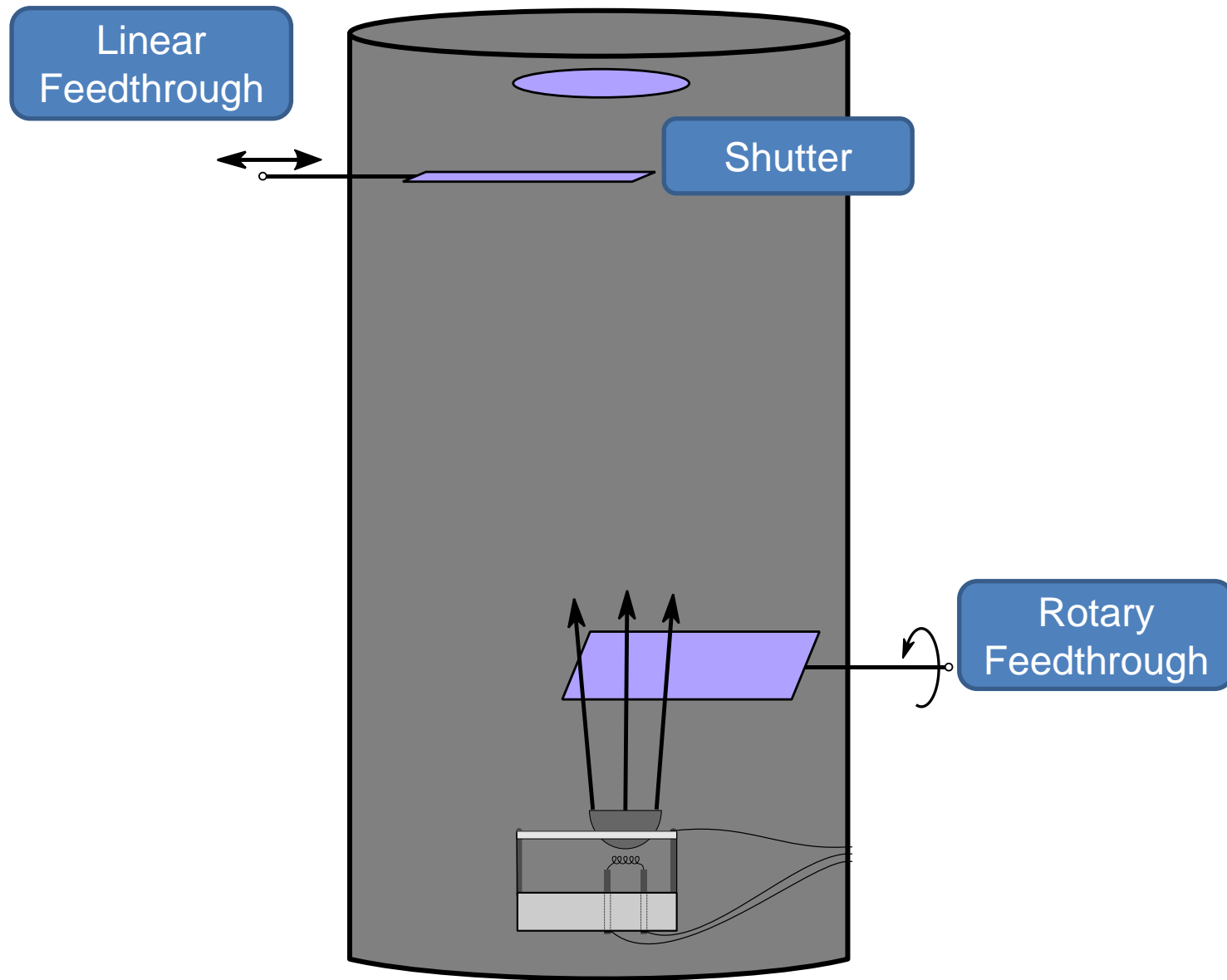
New Circuit Design



New Circuit Design



Future Work





Questions

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Phase Correction

$$\frac{1}{Z_T} = \frac{1}{Z_L} + \frac{1}{Z_C}$$

$$Z_L = \frac{V}{I} (\cos(\phi) - i \sin \phi) \qquad Z_C = i\omega C$$

$$\frac{I}{V \cdot 2\pi f} \sin \phi = C = 49 \mu F$$

